



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG791657400
Report verification at igi.org

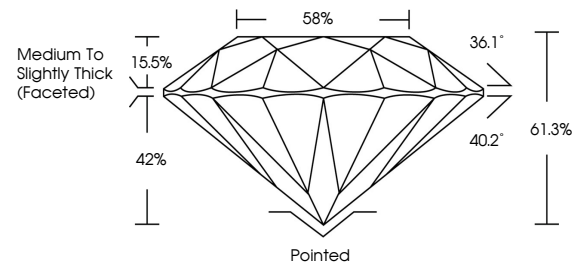
April 20, 2026	
IGI Report Number	LG791657400
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.29 - 7.34 X 4.48 MM
GRADING RESULTS	
Carat Weight	1.50 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	VERY GOOD
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG791657400

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

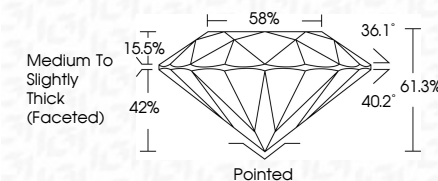
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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April 26, 2026	G Report No LG791657400	
ROUND BRILLIANT		
2.29 - 2.29 - 7.34 X 4.68 MM		
Carat Weight	1.60 CARAT	
Color Grade	D	
Clarity Grade	VVS 2	
Cut Grade	IDEAL	
Depth	61.3%	
Table	86%	
Girdle	Medium To Slightly Thick (Faceted)	
Quet	Parked	
Polish	VERY GOOD	
Symmetry	EXCELLENT	
Fluorescence	NONE	
Inscriptions(s)	#61 LG791657400	

Comments:
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Type IIa